ANNEX I

ANNEX I

GOODS AND TECHNOLOGY REFERRED TO IN ARTICLES 2 AND 3

All goods and technology listed in Annex I to Regulation (EC) No 428/2009.

ANNEX Ia

GOODS AND TECHNOLOGY REFERRED TO IN ARTICLES 2 AND 3

Other items, materials, equipment, goods and technology which could contribute to North Korea's nuclear-related, other weapons of mass destruction-related or ballistic missile-related programmes.

- 1. Unless otherwise stated, reference numbers used in the column entitled "Description" refer to the descriptions of dual use items and technology set out in Annex I to Regulation (EC) No 428/2009.
- 2. A reference number in the column entitled "Related item from Annex I to Regulation (EC) No 428/2009" means that the characteristics of the item described in the column "Description" lie outside the parameters set out in the description of the dual use entry referred to.
- 3. Definitions of terms between "single quotation marks" are given in a technical note to the relevant item.
- 4. Definitions of terms between "double quotation marks" can be found in Annex I to Regulation (EC) No 428/2009.

GENERAL NOTES

- 1. The object of the prohibitions contained in this Annex should not be defeated by the export of any non-prohibited goods (including plants) containing one or more prohibited components when the prohibited component or components are the principal element of the goods and can feasibly be removed or used for other purposes.
- N.B.: In judging whether the prohibited component or components are to be considered the principal element, it is necessary to weigh the factors of quantity, value and technological knowhow involved and other special circumstances which might establish the prohibited component or components as the principal element of the goods being procured.
- 2. Goods specified in this Annex include both new and used goods. **GENERAL TECHNOLOGY NOTE (GTN)**(To be read in conjunction with Part C)
- 1. The sale, supply, transfer or export of "technology" which is "required" for the "development", "production" or "use" of goods the sale, supply, transfer or export of which is prohibited in Part A (Goods) below, is prohibited in accordance with the provisions of Part B.
- 2. The "technology" "required" for the "development", "production" or "use" of prohibited goods remains under prohibition even when applicable to non-prohibited goods.

- 3. Prohibitions do not apply to that "technology" which is the minimum necessary for the installation, operation, maintenance (checking) and repair of those goods which are not prohibited.
- 4. Prohibitions on "technology" transfer do not apply to information "in the public domain", to "basic scientific research" or to the minimum necessary information for patent applications.

A. GOODS

NUCLEAR MATERIALS, FACILITIES, AND EQUIPMENT

I.A0.

GOODS

No	Description	Related item from Annex I to Regulation (EC) No 428/2009
I.A0.001	Hollow cathode lamps as follows: a. Iodine hollow cathode lamps with windows in pure silicon or quartz; b. Uranium hollow cathode lamps.	
I.A0.002	Faraday isolators in the wavelength range 500 nm – 650 nm	
I.A0.003	Optical gratings in the wavelength range 500 nm – 650 nm	
I.A0.004	Optical fibres in the wavelength range 500 nm – 650 nm coated with antireflecting layers in the wavelength range 500 nm – 650 nm and having a core diameter greater than 0,4 mm but not exceeding 2 mm.	
I.A0.005	Nuclear reactor vessel components and testing equipment, other than those specified in 0A001, as follows: a. Seals; b. Internal components;	0A001

	c. Sealing, testing and measurement equipment.	
I.A0.006	Nuclear detection systems, other than those specified in 0A001.j. or 1A004.c., for detection, identification or quantification of radioactive materials or radiation of nuclear origin and specially designed components thereof. <i>N.B: For personal equipment refer to I.A1.004 below.</i>	0A001.j. 1A004.c.
I.A0.007	Bellows-sealed valves other than those specified in 0B001.c.6., 2A226 or 2B350, made of aluminium alloy or stainless steel type 304, 304L or 316L.	0B001.c.6.2A226 2B350
I.A0.008	Laser mirrors, other than those specified in 6A005.e., consisting of substrates having a thermal expansion coefficient of 10 ⁻⁶ K ⁻¹ or less at 20 °C (e.g. fused silica or sapphire). Note: This item does not cover optical systems specially designed for astronomical applications, except if the mirrors contain fused silica.	0B001.g.5. 6A005.e.
I.A0.009	Laser lenses, other than those specified in 6A005.e.2, consisting of substrates having a thermal expansion coefficient of 10 ⁻⁶ K ⁻¹ or less at 20 °C (e.g. fused silica).	
I.A0.010	Pipes, piping, flanges, fittings made of, or lined with nickel, or nickel alloy containing more than 40 % nickel by weight, other than those specified in 2B350.h.1.	
I.A0.011	Vacuum pumps other than those specified in 0B002.f.2. or 2B231, as follows:	0B002.f.2. 2B231

	 a. Turbo-molecular pumps having a flow-rate equal to or greater than 400 l/s; b. Roots type vacuum roughing pumps having a volumetric aspiration flow-rate greater than 200 m³/h; c. Bellows-sealed, 	
	scroll, dry compressor, and bellows-sealed, scroll, dry vacuum pumps.	
I.A0.012	Shielded enclosures for the manipulation, storage and handling of radioactive substances (hot cells).	0B006
I.A0.013	"Natural uranium" or "depleted uranium" or thorium in the form of metal, alloy, chemical compound or concentrate and any other material containing one or more of the foregoing, other than those specified in 0C001.	0C001
I.A0.014	Detonation chambers having a capacity of explosion absorption of more than 2,5 kg TNT equivalent.	

SPECIAL MATERIALS AND RELATED EQUIPMENT

I.A1.

GOODS

No Description		Related item from Annex I to Regulation (EC) No 428/2009
I.A1.001	Bis(2-ethylhexyl) phosphoric acid (HDEHP or D2HPA) Chemical Abstract Number (CAS): [CAS 298-07-7] solvent in any quantity, with a purity greater than 90 %.	

		T
I.A1.002	Fluorine gas CAS: [7782-41-4], with a purity of at least 95 %.	
I.A1.003	Ring-shaped seals and gaskets, having an inner diameter of 400 mm or less, made of any of the following materials: a. Copolymers of vinylidene fluoride having 75 % or more beta crystalline structure without stretching; b. Fluorinated polyimides containing 10 % by weight or more of combined fluorine; c. Fluorinated phosphazene elastomers containing 30 % by weight or more of combined fluorine; d. Polychlorotrifluoroet (PCTFE, e.g. Kel-F®); e. Fluoro-elastomers (e.g., Viton ®, Tecnoflon ®); f. Polytetrafluoroethyle (PTFE).	
I.A1.004	Personal equipment for detecting radiation of nuclear origin, other than that specified in 1A004.c., including personal dosimeters.	1A004.c.
I.A1.005	Electrolytic cells for fluorine production, other than those specified in 1B225, with an output capacity greater than 100 g of fluorine per hour.	1B225
I.A1.006	Catalysts, other than those specified in 1A225 or 1B231, containing platinum, palladium or rhodium, usable for promoting the hydrogen isotope exchange reaction	1A225 1B231

	between hydrogen and water for the recovery of tritium from heavy water or for the production of heavy water.	
I.A1.007	Aluminium and its alloys, other than those specified in 1C002.b.4. or 1C202.a, in crude or semi-fabricated form having either of the following characteristics: a. "Capable of" an ultimate tensile strength of 460 MPa or more at 293 K (20 °C); or b. Having a tensile strength of 415 MPa or more at 298 K (25 °C). Technical note: The phrase alloys "capable of" encompasses alloys before or after heat treatment.	1C002.b.4. 1C202.a.
I.A1.008	Magnetic metals, of all types and of whatever form, other than those specified in 1C003.a. having an "initial relative permeability" of 120 000 or more and a thickness between 0,05 mm and 0,1 mm. Technical note: Measurement of "initial relative permeability" must be performed on fully annealed materials.	1C003.a.
I.A1.009	"Fibrous or filamentary materials" or prepregs, other than those specified in 1C010.a., 1C010.b., 1C210.a. or 1C210.b. as follows: a. Aramid "fibrous or filamentary materials" having either of the following characteristics: 1.A "specific modulus" exceeding	1C010.a. 1C010.b. 1C210.a. 1C210.b.

 10×10^{6} m; or 2.A "specific tensile strength" exceeding 17×10^4 m; b. Glass "fibrous or filamentary materials" having either of the following characteristics: "specific 1.A modulus" exceeding $3,18 \times 10^{6}$ m; or 2.A "specific tensile strength" exceeding 76.2×10^{3} m; Thermoset resinc. impregnated continuous "yarns",
"rovings", "tows"
or "tapes" with a width of 15 mm or less (once prepregs), made from glass "fibrous or filamentary materials" other than those specified in I.A1.010.a. below. d. Carbon "fibrous or filamentary materials"; Thermoset resine. impregnated continuous "yarns", "rovings", "tows", or "tapes", made from carbon "fibrous or filamentary materials";

	f. Polyacrylonitrile (PAN) continuous "yarns", "rovings", "tows" or "tapes". g. Para-aramid "fibrous or filamentary materials" (Kevlar® and other Kevlar®- like fibres).	
I.A1.010	Resin-impregnated or pitch-impregnated fibres (prepregs), metal or carboncoated fibres (preforms) or "carbon fibre preforms", as follows: a. Made from "fibrous or filamentary materials" specified in I.A1.009 above; b. Epoxy resin "matrix" impregnated carbon "fibrous or filamentary materials" (prepregs) specified in 1C010.a., 1C010.b. or 1C010.c., for the repair of aircraft structures or laminates, of which the size of individual sheets does not exceed 50 cm × 90 cm; c. Prepregs specified in 1C010.a., 1C010.b. or 1C010.c., when impregnated with phenolic or epoxy resins having a glass transition temperature (Tg) less than 433 K (160 °C) and a cure temperature lower than the glass transition temperature.	1C010 1C210

I.A1.011	Reinforced silicon carbide ceramic composites usable for nose tips, re-entry vehicles, nozzle flaps, usable in "missiles", other than those specified in 1C107.	1C107
I.A1.012	Not used	
I.A1.013	Tantalum, tantalum carbide, tungsten, tungsten carbide and alloys thereof, other than those specified in 1C226, having both of the following characteristics: a. In forms having a hollow cylindrical or spherical symmetry (including cylinder segments) with an inside diameter between 50 mm and 300 mm; and b. A mass greater than 5 kg.	1C226
I.A1.014	"Elemental powders" of cobalt, neodymium or samarium or alloys or mixtures thereof containing at least 20 % by weight of cobalt, neodymium or samarium, with a particle size less than 200 µm. Technical note: "Elemental powder" means a high purity powder of one element.	
I.A1.015	Pure tributyl phosphate (TBP) [CAS No 126-73-8] or any mixture having a TBP content of more than 5 % by weight.	
I.A1.016	Maraging steel, other than those specified by 1C116 or 1C216. Technical notes: 1. The phrase maraging steel "capable of" encompasses	1C116 1C216

maraging steel before or after heat treatment.

2. Maraging steels are iron alloys generally characterised by high nickel, very low carbon content and the use of substitutional elements or precipitates to produce strengthening and age-hardening of the alloy.

I.A1.017

Metals, metal powders and material as follows:
a. Tungsten and

tungsten alloys, other than those specified in 1C117, in the form of uniform spherical or atomized particles of 500 μm (micrometre) diameter or less with a tungsten content of 97 % by weight or more; b. Molybdenum and molybdenum alloys, other than those specified in 1C117, in the form of uniform spherical or atomized particles of 500 µm diameter or less with a molybdenum content of 97 % by weight or more; Tungsten materials c. in the solid form, other than those specified in 1C226

having material compositions as

follows:

1C117 1C226 Document Generated: 2023-10-27

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	1. Tungste and allo containi 97 % by weight of more of tungster containi 80 % by weight of more of tungster or 3. Silver infiltrate tungster containi 80 % by weight of more of tungster containi 80 % by weight of more of tungster containi 80 % by weight of more of tungster of tungster containi 80 % by weight of more of tungster containing the silver infiltrate tung	ys ng or a; ed a ng or a;
I.A1.018	Soft magnetic alloys, other than those specified in 1C003, having a chemical composition as follows: a	i
I.A1.019	Not used	
I.A1.020	Graphite, other than that specified in 0C004 or 1C107.a, designed or specified for use in Electric Discharge Machining (EDM machines	

MATERIALS PROCESSING

I.A2. **GOODS**

No	Description	Related item from Annex I to Regulation (EC) No 428/2009	
I.A2.001	Vibration test systems, equipment and components thereof, other than those specified in 2B116: a. Vibration test systems employing feedback or closed loop techniques and incorporating a digital controller, capable of vibrating a system at an acceleration equal to or greater than 0,1 g rms between 0,1 Hz and 2 kHz and imparting forces equal to or greater than 50 kN, measured "bare table"; b. Digital controllers, combined with specially designed vibration test "software", with a "real-time control bandwidth" greater than 5 kHz designed for use with vibration test systems specified in a.; Technical note: "Real-time control bandwidth" is defined as the maximum rate at which a controller can execute complete cycles of sampling, processing data and	2B116	

Manufacturers calculating positioning accuracy in accordance with ISO 230/2 (1997) should consult the competent authorities of the Member State in which they are established.

	c. Vibration thrusters (shaker units), with or without associated amplifiers, capable of imparting a force equal to or greater than 50 kN, measured "bare table", and usable in vibration test systems specified in a.; d. Test piece support structures and electronic units designed to combine multiple shaker units in a system capable of providing an effective combined force equal to or greater than 50 kN, measured "bare table", and usable in vibration systems specified in a. Technical note: "bare table " means a flat table, or surface, with no fixture or fittings.	
I.A2.002	Machine tools, other than those specified in 2B001.c. or 2B201.b., for grinding having positioning accuracies with "all compensations available" equal to or less (better) than 15 µm according to ISO 230/2 (1988) ^a or national equivalents along any linear axis.	2B001.c. 2B201.b.
I.A2.002a	Components and numerical controls, specially designed for machine tools specified in 2B001, 2B201, or I.A2.002 above.	
a Manufacturers calculating positioning authorities of the Member State in w	g accuracy in accordance with ISO 230/2 (hich they are established.	1997) should consult the competent

I.A2.003		ing machines an		2B119
		related equipment as follows:		
	a.			
	machines, designed		signed	
	or modified			
	for dental or			
		other medical		
		equipment, ha	aving	
		all the following		
	characteristics:		s:	
		1. Not		
		capa	able of	
			ncing	
		roto		
			mblies	
		hav		
		a m	-	
		grea		
			3 kg;	
			able of	
			ncing	
		roto		
			mblies	
			peeds	
		grea		
		than		
			rpm;	
			able of	
			ecting	
			alance	
		in ty		
		plar	ies or	
		mor	e; and	
		4. Cap	able of	
		bala	ncing	
		to a	-	
		resi	dual	
		spec	eific	
			alance	
		of 0		
			m per	
		kg a	of rotor	
		mas		
	b.	"Indicator he		
		designed or		
		modified for	use	
		with machine		
		specified in a		
		above.		
	Tacker	cal note:		
	recnn	cai note.		

a Manufacturers calculating positioning accuracy in accordance with ISO 230/2 (1997) should consult the competent authorities of the Member State in which they are established.

	"Indicator heads" are sometimes known as balancing instrumentation.	
I.A2.004	Remote manipulators that can be used to provide remote actions in radiochemical separation operations or hot cells, other than those specified in 2B225, having either of the following characteristics: a. A capability of penetrating a hot cell wall of 0,3 m or more (through the wall operation); or b. A capability of bridging over the top of a hot cell wall with a thickness of 0,3 m or more (over the wall operation). Technical note: Remote manipulators provide translation of human operator actions to a remote operating arm and terminal fixture. They may be of master/slave type or operated by joystick or keypad.	2B225
I A2.005	Controlled atmosphere heat treatment furnaces or oxidation furnaces capable of operation at temperatures above 400 °C Note: This item does not cover tunnel kilns with roller or car conveyance, tunnel kilns with conveyor belt, pusher type kilns or shuttle kilns, specially designed for the production of glass, tableware ceramics or structural ceramics.	2B226 2B227
I.A2.006	Not used	
I.A2.007	"Pressure transducers", other than those defined in 2B230, capable of measuring	2B230

a Manufacturers calculating positioning accuracy in accordance with ISO 230/2 (1997) should consult the competent authorities of the Member State in which they are established.

	absolute pressures at any point in the range 0 to 200 kPa and having both of the following characteristics: a. Pressure sensing elements made of or protected by "Materials resistant to corrosion by uranium hexafluoride (UF ₆)", and b. Having either of the following characteristics: 1. A full scale of less than 200 kPa and an "accuracy" of better than ± 1 % of full scale; or 2. A full scale of 200 kPa or greater and an "accuracy" of better than 2 kPa. Technical note: For the purposes of 2B230, "accuracy" includes non-	
	linearity, hysteresis and repeatability at ambient temperature.	
I.A2.008 a Manufacturers calculating positionin	Liquid-liquid contacting equipment (mixer-settlers, pulsed columns, centrifugal contactors); and liquid distributors, vapour distributors or liquid collectors designed for such equipment, where all surfaces that come in direct contact with the chemical(s) being g accuracy in accordance with ISO 230/2 (2B350.e.
authorities of the Member State in w	hich they are established.	

	processed are made from any	
	processed are made from any of the following materials:	
	a. Alloys with more	
	than 25 % nickel	
	and 20 % chromium	
	by weight;	
	b. Fluoropolymers;	
	c. Glass (including	
	vitrified or	
	enamelled coating	
	or glass lining);	
	d. Graphite or "carbon	
	graphite";	
	e. Nickel or alloys	
	with more than	
	40 % nickel by	
	weight; f. Tantalum or	
	tantalum alloys;	
	g. Titanium or	
	titanium alloys;	
	h. Zirconium or	
	zirconium alloys; or	
	i. Stainless steel.	
	Technical note:	
	"Carbon graphite" is a	
	composition consisting of	
	amorphous carbon and	
	graphite, in which the	
	graphite content is 8 % or more by weight.	
I.A2.009	Industrial equipment and	2B350.d.
	components, other than those	
	specified in 2B350.d., as	
	follows:	
	Heat exchangers or condensers with a heat	
	transfer surface area greater	
	than 0.05 m^2 , and less than	
	30 m ² ; and tubes, plates, coils	
	or blocks (cores) designed	
	for such heat exchangers	
	or condensers, where all	
	surfaces that come in direct	
	contact with the fluid(s)	
	are made from any of the	
	following materials:	
	a. Alloys with more	
	than 25 % nickel	
a Manufacturers calculating positionin authorities of the Member State in w	g accuracy in accordance with ISO 230/2 (hich they are established.	1997) should consult the competent

Manufacturers calculating	which all surfaces	that come	1
	(pump bodies), pro casing liners, importors or jet pump designed for such	ellers, nozzles	
	[measured under s temperature (273 l and pressure (101, conditions]; and ca	tandard K or 0 °C) 3 kPa) asings	
	than 0,6 m ³ /hour, or pumps with manufacture greater than 5	or vacuum facturer's m flow-	
	pumps, other than specified in 2B350 for corrosive fluid manufacturer's specified maximum flow-rain flow-r	O.i, suitable s, with ecified	
.A2.010	heat exchanger. Multiple-seal, and	seal-less 2B350.i.	
	functions do not de the status of contro	etermine	
	The materials used gaskets and seals dimplementation of	and other	
	Technical note:		
	Note: This item do cover vehicle radi	es not	
		carbide; or	
	zirconiui i. Silicon c	n alloys;	
	titanium h. Zirconiu	3	
	tantalum g. Titanium	•	
	with more 40 % nic weight; f. Tantalun	kel by 1 or	
	graphite' e. Nickel o	r alloys	
	or glass d. Graphite	or "carbon	
	c. Glass (in vitrified	cluding	
	by weigh b. Fluoropo		

	in direct contact with the chemical(s) being processed are made from any of the following materials: a. Alloys with more than 25 % nickel and 20 % chromium by weight; b. Ceramics; c. Ferrosilicon; d. Fluoropolymers; e. Glass (including vitrified or enamelled coatings or glass lining); f. Graphite or "carbon graphite"; g. Nickel or alloys with more than 40 % nickel by weight; h. Tantalum or tantalum alloys; i. Titanium or titanium alloys; j. Zirconium or zirconium alloys; k. Niobium (columbium) or niobium alloys; l. Stainless Steel; or m. Aluminium Alloys. Technical note: The materials used for gaskets and seals and other implementation of sealing functions do not determine the status of control of the	
1.42.011	pump.	2D252
I.A2.011	"Centrifugal separators", other than those specified in 2B352.c., capable of continuous separation without the propagation of aerosols and manufactured from: a. Alloys with more than 25 % nickel and 20 % chromium by weight;	2B352.c.
a Manufacturers calculating positionin authorities of the Member State in w	g accuracy in accordance with ISO 230/2 (hich they are established.	

	b. Fluoropolymers; c. Glass (including vitrified or enamelled coating or glass lining); d. Nickel or alloys with more than 40 % nickel by weight; e. Tantalum or tantalum alloys; f. Titanium or titanium alloys; or g. Zirconium or zirconium alloys. Technical note: "Centrifugal separators" include decanters.	
I.A2.012	Sintered metal filters, other than those specified in 2B352.d., made of nickel or nickel alloy with more than 40 % nickel by weight.	2B352.d.
I.A2.013	Spin-forming machines and flow-forming machines, other than those specified by 2B009, 2B109 or 2B209 and specially designed components therefor. Technical note: For the purpose of this item, machines combining the functions of spin-forming and flow-forming are regarded as flow-forming machines.	2B009 2B109 2B209

Manufacturers calculating positioning accuracy in accordance with ISO 230/2 (1997) should consult the competent authorities of the Member State in which they are established.

ELECTRONICS

I.A3.

GOODS

No	Description	Related item from Annex I to Regulation (EC) No 428/2009
I.A3.001	High voltage direct current power supplies, other than those specified in 0B001.j.5.	0B001.j.5. 3A227

or 3A227, having both of the following characteristics:

- a. Capable of continuously producing, over a time period of eight hours, 10 kV or more, with output power of 5 kW or more with or without sweeping; and
- b. Current or voltage stability better than 0,1 % over a time period of four hours.

I.A3.002

Mass spectrometers, other than those specified in 0B002.g or 3A233, capable of measuring ions of 200 atomic mass units or more and having a resolution of better than 2 parts in 200, as follows, and ion sources therefor:

- a. Inductively coupled plasma mass spectrometers (ICP/MS);
- b. Glow discharge mass spectrometers (GDMS);
- c. Thermal ionisation mass spectrometers (TIMS);
- d. Electron
 bombardment
 mass spectrometers
 which have a
 source chamber
 constructed
 from, lined with
 or plated with
 "materials resistant
 to corrosion
 by uranium
 hexafluoride UF₆";
- e. Molecular beam mass spectrometers having either of

0B002.g 3A233

I.A3.003

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f.

a.

b.

operating in the frequency range

the following characteristics: 1. A source chamber constructed from, lined with or plated with stainless steel or molybdenum and equipped with a cold trap capable of cooling to 193 K $(-80 \, ^{\circ}\text{C})$ or less; or 2. A source chamber constructed from, lined with or plated with materials resistant to UF_6 ; Mass spectrometers equipped with a micro-fluorination ion source designed for actinides or actinide fluorides. Frequency changers or 0B001.b.13. generators, other than those 3A225 specified by 0B001.b.13 or3A225, having all of the following characteristics, and specially designed components and software therefor: Multiphase output capable of providing a power of 40 W or greater; Capable of

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	between 600 and 2 000 Hz; and c. Frequency control better (less) than 0,1 %. Technical notes:
	1. Frequency changers are also known as converters, inverters, generators, electronic test equipment, AC power supplies, variable speed motor drives or variable frequency drives.
	2. The functionality specified in this item may be met by certain equipment marketed as; electronic test equipment, AC power supplies, variable speed motor drives or variable frequency drives.
I.A3.004	Spectrometers and diffractometers, designed for the indicative test or quantitative analysis of the elemental composition of metals or alloys without chemical decomposition of the material.

SENSORS AND LASERS

I.A6.

GOODS

No	Description	Related item from Annex I to Regulation (EC) No 428/2009
I.A6.001	Yttrium aluminium garnet (YAG) rods.	

I.A6.002	Optical equipment and components, other than those specified in 6A002 or 6A004.b as follows: Infrared optics in the wavelength range 9 µm – 17 µm and components thereof, including cadmium telluride (CdTe) components.	6A002 6A004.b.
I.A6.003	Wave front corrector systems, other than mirrors specified in 6A004.a, 6A005.e or 6A005.f., for use with a laser beam having a diameter exceeding 4 mm, and specially designed components thereof, including control systems, phase front sensors and "deformable mirrors" including bimorph mirrors.	6A004.a. 6A005.e. 6A005.f.
I.A6.004	Argon ion "lasers", other than those specified in 0B001.g.5, 6A005 and or 6A205.a., having an average output power equal to or greater than 5 W.	0B001.g.5. 6A005.a.6. 6A205.a.
I.A6.005	Semiconductor "lasers", other than those specified in 0B001.g.5., 0B001.h.6. or 6A005.b., and components thereof, as follows: a. Individual semiconductor "lasers" with an output power greater than 200 mW each, in quantities larger than 100; b. Semiconductor "laser" arrays having an output power greater than 20 W. Notes: 1. Semiconductor "lasers" are commonly called "laser" diodes.	0B001.g.5. 0B001.h.6. 6A005.b.

	2. This item does not cover "laser" diodes with a wavelength in the range 1,2 μm – 2,0 μm.	
I.A6.006	Tunable semiconductor "lasers" and tunable semiconductor "laser" arrays, other than those specified in 0B001.h.6. or 6A005.b., of a wavelength between 9 µm and 17 µm, as well as array stacks of semiconductor "lasers" containing at least one tunable semiconductor "laser" array of such wavelength. Note: Semiconductor "lasers" are commonly called "laser" diodes.	0B001.h.6. 6A005.b.
I.A6.007	Solid state "tunable" "lasers", other than those specified in 0B001.g.5., 0B001.h.6. or 6A005.c.1., and specially designed components thereof as follows: a. Titanium-sapphire lasers, b. Alexandrite lasers.	0B001.g.5. 0B001.h.6. 6A005.c.1.
I.A6.008	Neodymium-doped (other than glass) "lasers", other than those specified in 6A005.c.2.b., having an output wavelength greater than 1,0 µm but not exceeding 1,1 µm and output energy exceeding 10 J per pulse.	6A005.c.2.b.
I.A6.009	Components of acousto- optics, as follows: a. Framing tubes and solid-state imaging devices having a recurrence frequency equal to or exceeding 1 kHz; b. Recurrence frequency supplies;	6A203.b.4.

	c. Pockels cells.	
I.A6.010	Radiation-hardened cameras, or lenses thereof, other than those specified in 6A203.c., specially designed, or rated as radiation-hardened, to withstand a total radiation dose greater than 50×10^3 Gy(silicon) (5×10^6 rad (silicon)) without operational degradation. Technical note: The term Gy(silicon) refers to the energy in Joules per kilogram absorbed by an unshielded silicon sample when exposed to ionising radiation.	6A203.c.
I.A6.011	Tunable pulsed dye laser amplifiers and oscillators, other than those specified in 0B001.g.5, 6A005 and or 6A205.c., having all of the following characteristics: a. Operating at wavelengths between 300 nm and 800 nm; b. An average output power greater than 10 W but not exceeding 30 W; c. A repetition rate greater than 1 kHz; and d. Pulse width less than 100 ns. Note: This item does not cover single mode oscillators.	0B001.g.5. 6A005 6A205.c.
I.A6.012	Pulsed carbon dioxide "lasers", other than those specified in, 0B001.h.6., 6A005.d. or 6A205.d., having all of the following characteristics: a. Operating at wavelengths between 9, µm and 11 µm;	0B001.h.6. 6A005.d. 6A205.d.

b.	A repetition rate greater than 250 Hz;	
c.	An average output power greater than 100 W but not exceeding 500 W; and	
d.	Pulse width less than 200 ns.	

NAVIGATION AND AVIONICS

I.A7.

GOODS

No	Description	Related item from Annex I to Regulation (EC) No 428/2009
I.A7.001	Inertial navigation systems and specially designed components thereof, as follows: a. Inertial navigation systems which are certified for use on "civil aircraft" by civil authorities of a State participating in the Wassenaar Arrangement, and specially designed components thereof as follows: 1. Inertial navigation systems (INS) (gimballed or strapdown and inertial equipment designed for "aircraft", land vehicle, vessels (surface or	

```
underwater)
"spacecraft"
for
attitude,
guidance
or control,
having
any of the
following
characteristics,
and
specially
designed
components
thereof:
         Navigation
a.
         error
         (free
         inertial)
         subsequent
         to
         normal
         alignment
         of
         0,8
         nautical
         mile
         per
         hour
         (nm/
         hr)
         "¢ircular
         Error
         Probable" (CEP)
         or
         less
         (better);
         or
b.
         Specified
         to
         function
         at
         linear
         acceleration
         levels
         exceeding
         10
         g;
Hybrid
Inertial
Navigation
Systems
```

2.

embedded with Global Navigation Satellite Systems(s) (GNSS) or with "Data-Based Referenced Navigation" ("DBRN") System(s) for attitude, guidance or control, subsequent to normal alignment, having an INS navigation position accuracy, after loss of GNSS or "DBRN" for a period of up to four minutes, of less (better) than 10 metres "Circular Error Probable" (CEP); Inertial Equipment for Azimuth, Heading, or North Pointing having any of the following characteristics, and

3.

specially

designed

```
components
                   thereof:
                            Designed
                   a.
                            to
                            have
                            an
                            Azimuth,
                            Heading,
                            or
                            North
                            Pointing
                            accuracy
                            equal
                            to
                            or
                            less
                            (better)
                            than
                            6
                            arc
                            minutes
                            RMS
                            at
                            45
                            degrees
                            latitude;
                            or
                   b.
                            Designed
                            to
                            have
                            non-
                            operating
                            shock
                            level
                            of
                            at
                            least
                            900
                            g
                            at
                            a
                            duration
                            of
                            at
                            least
                            1
                            msec.
         Theodolite systems
b.
         incorporating
         inertial equipment
         specially designed
```

for civil surveying purposes and designed to have an Azimuth, Heading, or North Pointing accuracy equal to, or less (better) than 6 arc minutes RMS at 45 degrees latitude, and specially designed components thereof. c. Inertial or other equipment using accelerometers specified in 7A001 or 7A101, where such accelerometers are specially designed and developed as MWD (Measurement While Drilling) sensors for use in down-hole well services operations.

Note: The parameters of a.1. and a.2. are applicable with any of the following environmental conditions:

1. Input random vibration with an overall magnitude of 7,7 g rms in the first half hour and a total test duration of one and a half hours per axis in each of the three perpendicular axes, when the random vibration meets the following:

a. A constant
power
spectral
density
(PSD)
value of
0,04 g²/
Hz over a
frequency
interval

```
of 15 to 1
         000 Hz;
         and
b.
         The PSD
         attenuates
         with a
         frequency
         from 0,04
         g^2/Hz to
         0.01 \, g^2 /
         Hz over a
         frequency
         interval
         from 1 000
         to 2 000
         Hz;
```

- 2. A roll and yaw rate equal to or greater than +2,62 radian/s (150 deg/s); or
- 3. According to national standards equivalent to 1. or 2. above.

Technical notes:

- 1. a.2. refers to systems in which an INS and other independent navigation aids are built into a single unit (embedded) in order to achieve improved performance.
- 2. "Circular Error Probable" (CEP)

 In a circular normal distribution, the radius of the circle containing 50 percent of the individual measurements being made, or the radius of the circle within which there is a 50 percent probability of being located.

I.A9.

GOODS

No	Description	Related item from Annex I to Regulation (EC) No 428/2009
I.A9.001	Explosive bolts.	

B. SOFTWARE

No	Description	Related item from Annex I to Regulation (EC) No 428/2009
I.B.001	Software required for the development, production or use of the items in Part A. (Goods).	

C. TECHNOLOGY

No	Description	Related item from Annex I to Regulation (EC) No 428/2009
I.C.001	Technology required for the development, production or use of the items in Part A. (Goods).	

ANNEX II

ANNEX IV

List of persons, entities and bodies referred to in Article 6(1)

A. Natural persons:

- (1) **Han** Yu-ro. Post: Director of Korea Ryongaksan General Trading Corporation. Other information: involved in North Korea's ballistic missile programme. Date of designation: 16.7.2009.
- (2) **Hwang** Sok-hwa. Post: Director of the General Bureau of Atomic Energy (GBAE). Other information: involved in North Korea's nuclear programme as Chief of the Scientific Guidance Bureau in the GBAE, served on the Science Committee in the Joint Institute for Nuclear Research. Date of designation: 16.7.2009.

- (3) **Ri** Hong-sop. Year of birth: 1940. Post: Former director, Yongbyon Nuclear Research Centre. Other information: oversaw three core facilities that assist in the production of weapons-grade plutonium: the Fuel Fabrication Facility, the Nuclear Reactor, and the Reprocessing Plant. Date of designation: 16.7.2009.
- (4) **Ri** Je-son (alias Ri Che-son). Year of birth: 1938. Post: Director of the General Bureau of Atomic Energy (GBAE), chief agency directing North Korea's nuclear programme. Other information: facilitates several nuclear endeavours including GBAE's management of Yongbyon Nuclear Research Centre and Namchongang Trading Corporation. Date of designation: 16.7.2009.
- (5) **Yun** Ho-jin (alias **Yun** Ho-chin). Date of birth: 13.10.1944. Post: Director of Namchongang Trading Corporation. Other information: oversees the import of items needed for the uranium enrichment programme. Date of designation: 16.7.2009.
- B. Legal persons, entities and bodies
 - (1) Korea Mining Development **Trading Corporation** (aka CHANGGWANG SINYONG CORPORATION; (b) **EXTERNAL** TECHNOLOGY GENERAL CORPORATION; (c) DPRKN MINING DEVELOPMENT TRADING COOPERATION; (d) "KOMID"). Address: Central District, Pyongyang, DPRK. Other information: Leading arms dealer and main exporter of goods and equipment related to ballistic missiles and conventional weapons. Date of designation: 24.4.2009.
 - (2) Korea Ryonbong General Corporation (aka (a) KOREA YONBONG GENERAL CORPORATION; (b) LYONGAKSAN GENERAL TRADING CORPORATION). Address: Pot'onggang District, Pyongyang, DPRK; Rakwon-dong, Pothonggang District, Pyongyang, DPRK. Other information: Defence conglomerate specialising in acquisition for DPRK defence industries and support to that country's military-related sales. Date of designation: 24.4.2009.
 - (3) Tanchon Commercial Bank (aka (a) CHANGGWANG CREDIT BANK; (b) KOREA CHANGGWANG CREDIT BANK). Address: Saemul 1-Dong Pyongchon District, Pyongyang, DPRK. Other information: Main DPRK financial entity for sales of conventional arms, ballistic missiles, and goods related to the assembly and manufacture of such weapons. Date of designation: 24.4.2009.
 - (4) General Bureau of Atomic Energy (GBAE) (aka General Department of Atomic Energy (GDAE)). Address: Haeudong, Pyongchen District, Pyongyang, DPRK. Other information: The GBAE is responsible for North Korea's nuclear programme, which includes the Yongbyon Nuclear Research Centre and its 5-MWe (25-MWt) plutonium production research reactor, as well as its fuel fabrication and reprocessing facilities. The GBAE has held nuclear-related meetings and discussions with the International Atomic Energy Agency. GBAE is the primary North Korean Government agency for overseeing nuclear programmes, including the operation of the Yongbyon Nuclear Research Centre. Date of designation: 16.7.2009.

- (5) **Hong Kong Electronics** (aka Hong Kong Electronics Kish Co.). Address: Sanaee St., Kish Island, Iran. Other information: (a) owned or controlled by, or acts or purports to act for or on behalf of Tanchon Commercial Bank and KOMID; (b) Hong Kong Electronics has transferred millions of dollars of proliferation-related funds on behalf of Tanchon Commercial Bank and KOMID (both designated by the UN Sanctions Committee in April 2009) since 2007. Hong Kong Electronics has facilitated the movement of money from Iran to North Korea on behalf of KOMID. Date of designation: 16.7.2009.
- (6) Korea Hyoksin Trading Corporation (aka Korea Hyoksin Export And Import Corporation). Address: Rakwon-dong, Pothonggang District, Pyongyang, DPRK. Other information: (a) located in Pyongyang, DPRK; (b) subordinate to Korea Ryonbong General Corporation (designated by the UN Sanctions Committee in April 2009) and is involved in the development of weapons of mass destruction. Date of designation: 16.7.2009.
- (7) **Korean Tangun Trading Corporation**. Other information: (a) located in Pyongyang, DPRK; (b) Korea Tangun Trading Corporation is subordinate to the DPRK's Second Academy of Natural Sciences and is primarily responsible for the procurement of commodities and technologies to support North Korea's defence research and development programmes, including, but not limited to, weapons of mass destruction and delivery system programmes and procurement, including materials that are controlled or prohibited under relevant multilateral control regimes. Date of designation: 16.7.2009.
- Namchongang Trading Corporation (aka (a) NCG, (b) Namchongang Trading, (c) Nam Chon Gang Corporation, (d) Nomchongang Trading Co., (e) Nam Chong Gan Trading Corporation). Other information: (a) located in Pyongyang, DPRK; (b) Namchongang is a North Korean trading company subordinate to the GBAE. Namchongang has been involved in the procurement of Japanese-origin vacuum pumps that were identified at a North Korean nuclear facility, as well as nuclear-related procurement associated with a German individual. It has further been involved in the purchase of aluminium tubes and other equipment specifically suitable for a uranium enrichment programme from the late 1990s. Its representative is a former diplomat who served as North Korea's representative for the IAEA inspection of the Yongbyon nuclear facilities in 2007. Namchongang's proliferation activities are of grave concern given North Korea's past proliferation activities. Date of designation: 16.7.2009

ANNEX III

'ANNEX V

LIST OF PERSONS, ENTITIES AND BODIES REFERRED TO IN ARTICLE 6(2)

A.

PERSONS

#	Name (and possible aliases)	Identifying information	Reasons
1.	CHANG Song-taek (alias JANG Song- Taek)	Date of birth: 2.2.1946 or 06.02.1946 or 23.02.1946 (North Hamgyong province) Passport number (as of 2006): PS 736420617	Member of the National Defence Commission. Director of the Administrative Department of the Korean Workers' Party.
2.	CHON Chi Bu		Member of the General Bureau of Atomic Energy, former technical director of Yongbyon.
3.	CHU Kyu-Chang (alias JU Kyu-Chang)	Date of birth: between 1928 and 1933	First Deputy Director of the Defence Industry Department (ballistics programme), Korean Workers' Party, Member of the National Defence Commission.
4.	HYON Chol-hae	Year of birth: 1934 (Manchuria, China)	Deputy Director of the General Political Department of the People's Armed Forces (military adviser to Kim Jong II).
5.	JON Pyong-ho	Year of birth: 1926	Secretary of the Central Committee of the Korean Workers' Party, Head of the Central Committee's Military Supplies Industry Department controlling the

			Second Economic Committee of the Central Committee, member of the National Defence Commission.
6.	KIM Tong-un	Year of birth: 1936 Passport number: 554410660	Director of "Office 39" of the Central Committee of the Workers' Party, which is involved in proliferation financing.
7.	KIM-Yong-chun (alias Young-chun)	Date of birth: 04.03.1935	Deputy Chairman of the National Defence Commission, Minister for the People's Armed Forces, special adviser to Kim Jong Il on nuclear strategy.
8.	O Kuk-Ryol	Year of birth: 1931 (Jilin Province, China)	Deputy Chairman of the National Defence Commission, supervising the acquisition abroad of advanced technology for nuclear and ballistics programmes.
9.	PAEK Se-bong	Year of birth: 1946	Chairman of the Second Economic Committee (responsible for the ballistics programme) of the Central Committee of the Korean Workers' Party. Member of the National Defence Commission.
10.	PAK Jae-gyong (alias Chae-Kyong)	Year of birth: 1933 Passport number: 554410661	Deputy Director of the General Political Department of the People's Armed Forces and Deputy Director of the Logistics Bureau of the People's Armed Forces (military

			adviser to Kim Jong II).
11.	PYON Yong Rip (alias Yong-Nip)	Date of birth: 20.09.1929 Passport number: 645310121 (issued on 13.09.2005)	President of the Academy of Science, involved in WMD- related biological research.
12.	RYOM Yong		Director of the General Bureau of Atomic Energy (entity designated by the United Nations), in charge of international relations.
13.	SO Sang-kuk	Year of birth: between 1932 and 1938	Head of the Department of Nuclear Physics, Kim Il Sung University.

B.

ENTITIES AND BODIES

#	Name (and possible aliases)	Identifying information	Reasons
1.	Yongbyon Nuclear Research Centre		Research centre which has taken part in the production of military-grade plutonium. Centre maintained by the General Bureau of Atomic Energy (entity designated by the United Nations, 16.07.2009).
2.	Korea Pugang Mining and Machinery Corporation ltd		Subsidiary of Korea Ryongbong General Corporation (entity designated by the United Nations, 24.04.2009); operates facilities for the production of aluminium powder, which can be used in missiles.

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3.	Korean Ryengwang Trading Corporation	Subsidiary of Korea Ryongbong General Corporation (entity designated by the United Nations, 24.04.2009).
4.	Sobaeku United Corp. (alias Sobaeksu United Corp.)	State-owned company, involved in research into, and the acquisition of, sensitive products and equipment. It possesses several deposits of natural graphite, which provide raw material for two processing facilities which, inter alia, produce graphite blocks that can be used in missiles.'

ANNEX IV

ANNEX VI

LIST OF CREDIT AND FINANCIAL INSTITUTIONS, BRANCHES AND SUBSIDIARIES REFERRED TO IN ARTICLE 11A